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LFw/B

In re Patent Application of: Dirk Basting et al.

Atty Docket No. LMPY-20310 [238/U]

Application No.: 10/699,763

Filed: November 3, 2003

Confirmation No.: 4236

For: EXCIMER OR MOLECULAR FLUORINE LASER SYSTEM WITH PRECISION TIMING

M/S ISSUE FEE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Transmittal herewith is an amendment in the above-identified application.

The fee has been calculated as shown below.

	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL	14	MINUS	49	0	x \$50 =	\$0
INDEP.	2	MINUS	7	0	x \$200 =	\$0
FIRST PRESENTATION OF MULTIPLE DEP CLAIMS					+ \$360	\$0
TOTAL						\$0

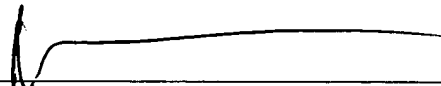
Small Entity 50% Filing Fee Reduction (if applicable) \$0

- * If the entry in Col. 1 is less than the entry in Col. 2, write "0" in Col. 3
** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.
*** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space. The "Highest Number Previously Paid For" (Total or Independent) is the highest number found from the equivalent box in Col. 1 of a prior amendment or the number of claims originally filed.)

- ☒ No additional fee is required.
- ☐ A check in the amount of \$_____ is attached.
- ☒ Please charge any additional fees, including any fees necessary for extensions of time or credit overpayment to Deposit Account No. 50-1703, under Order No. LMPY-20310.
A duplicate copy of this sheet is enclosed.
- ☐ Petition for extension of time. The undersigned attorney of record hereby petitions for an extension of time pursuant to 37 C.F.R. § 1.136(a), as may be required, to file this response.

STALLMAN & POLLOCK LLP

Dated: January 12, 2007

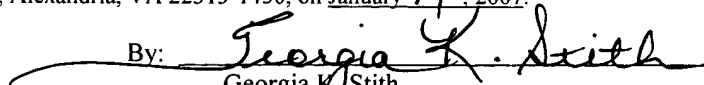
By: 
Michael A. Stallman (Reg. No. 29,444)
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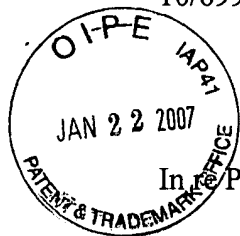
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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on January 17, 2007.

Dated: January 17, 2007

By:


Georgia K. Stith



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Patent Application of

Dirk Basting et al.

Application No.: 10/699,763

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FLUORINE LASER SYSTEM WITH
PRECISION TIMING

Confirmation No.: 4237

Group Art Unit: 2828

Examiner: Dung T. Nguyen

**COMMENTS ON STATEMENT OF
REASONS FOR ALLOWANCE**353 Sacramento Street, Suite 2200
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P.O. Box 1450

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STALLMAN & POLLOCK LLP

Dated: 01/17/2007By: Georgia K. Stith

Georgia K. Stith

Sir:

In response to the Notice of Allowance Dated January 10, 2007, Applicants
submit the following comments:

REMARKS


In a telephone conference initiated by the Examiner on December 8, 2006, the Nakao patent application (2006/0239307) was discussed. Applicants' counsel pointed out that Nakao failed to teach or suggest the subject matter of claim 50 as previously submitted. Although the Examiner appeared to understand the arguments, he offered to allow claim 50 if it was amended with the subject matter of claim 51. Applicants' counsel acquiesced to the Examiner's request solely to expedite prosecution and not because he believed that claim 50 prior to amendment was

taught or suggested by Nakao. The Examiner had indicated that claim 59 was allowable so claim 59 was not otherwise discussed.

Respectfully submitted,

STALLMAN & POLLOCK LLP

Dated: January 12, 2007

By: 
Michael A. Stallman
Reg. No. 29,444

Attorneys for Applicant(s)